

PRODUCT/PROCESS CHANGE NOTIFICATION

PCN HED-AUD/07/2782 Notification Date 07/30/2007

SO28 PACKAGE IN AMKOR ATP1 ASSEMBLY INTRODUCTION AS SECOND SOURCE

AUD - AUDIO

Table 1. Change Identification

Product Identification (Product Family/Commercial Product)	Audio Division products in SO28 line
Type of change	Package assembly location change
Reason for change	To increase assembly capacity
Description of the change	Following Divisional commitments towards a continuous improvment of our service and to increase our capacity, the subcontractor AMKOR ATP1 subcontractor assembly plant is fully operative for SO28 package. Due to the changes introduced on AMKOR ATP1 SO28 leadfree package, production will be with Molding compound Sumitomo G600 and Die attach material Ablestick 8290. Qualification Certificate QC-96-06-B and samples will be available upon request.
Product Line(s) and/or Part Number(s)	See attached
Description of the Qualification Plan	See attached
Change Product Identification	"PHL" as production area code for AMKOR ATP1
Manufacturing Location(s)	1]St Muar - Malaysia

Table 2. Change Implementation Schedule

Forecasted implementation date for change	23-Oct-2007
Forecasted availabillity date of samples for customer	01-Aug-2007
Forecasted date for STMicroelectronics change Qualification Plan results availability	23-Jul-2007
Estimated date of changed product first shipment	29-Oct-2007

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Table 3. L	ist of	Attachme	nts
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Customer Part numbers list	
Qualification Plan results	

Notification Date 07/30/2007
ame:
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A7/.

DOCUMENT APPROVAL

Name	Function
Onetti, Andrea Mario	Division Marketing Manager
Angelici, Marco	Division Product Manager
Piccoli, Massimo	Division Q.A. Manager

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SO28 PACKAGE IN AMKOR ATP1 ASSEMBLY INTRODUCTION AS SECOND SOURCE

WHAT:

Following Divisional commitments towards a continuous improvement of our service and to increase our capacity, we would like to inform you the subcontractor AMKOR ATP1 subcontractor assembly plant is fully operative for SO28 package.

Audio products affected by this change are:

Sales Type	Line
TDA7468D & TDA7468D13TR	A207
TDA7438D & TDA7438D13TR	A563
TDA7439DS & TDA7439DS13TR	A563
TDA7440D & TDA7440D13TR	A563

Due to the changes introduced on AMKOR ATP1 SO28 package, production will be with Molding compound Sumitomo G600 and Die attach material Ablestick 8290.

WHY:

To increase assembly capacity.

HOW:

Reliability Report 8066236 covers all the changes involved in this PCN.

WHEN:

From October 07 deliveries onward.

DATE 19-JUL-2007

HED BE Q&R RELIABILITY REPORT*

SO line Pure Tin – AMKOR-ATP1 **Assembly line:**

Package family: SO28 (LR package code)

Abstract

The object of this reliability report is to validate the introduction of the pure tin finishing and the molding compound (G600) change.

Change identification

Reliability report reference / date	HPC-Rel-33-06-B	June 5, 2007
Qualification request reference /date	HPC 0063/05	December 7, 2005
Qualification plan reference / date	HPC QP06010	April 25, 2006
Affected products	SO 28 lead free	

Conclusion

Based on the results of reliability tests and TI, all SO 28 with pure tin finishing can be considered as qualified with JEDEC level 3 @260°C (peak reflow temperature).

Approved by Massimo PICCOLI

HED BE Q&R - GRENOBLE Issued by Corinne TRIOMPHE

DATE 19-JUL-2007

Package construction note

PACKAGE FEATURES				
Package name SO 28 .30 TO JEDEC MS-013A				
Body size (mm ³)	18 x 7.5 x 2.3			
	1.27			
Pitch (mm)				
Assembly site	AMKOR ATP1			
Lead finish	Pure Tin			
Solder plating machine	MECO			
Solder plating chemistry	EXCEL 90			
Die attach	Ablestik 8290			
Molding compound	Resin Sumitomo G600			
Wire material / diameter GOLD WIRE 1.2 MILS D				
Wire bonding Thermosonic				

Test vehicles definition

DIE & PRODUCT FEATURES					
Technical code/ Line	A563 A521		A207		
RL Code	D5LR*A563BAZ	ECLR*A521ABQ	B5LR*A207BAH		
Pad size (µm²)	3810 x 3810	3810 x 3810	3810 x 3810		
Ground wires	No	No	No		
Diffusion process	B3 HF2CMOS	B3 HF2CMOS	B3 HF2CMOS		
Diffusion plant	Carrolton non HP	Carrolton non HP	Carrolton non HP		
Wafer diameter	6"	6"	6"		
Wafer thickness (µm)	375	375	375		
Die size (µm²)	2840 x 2250	2680 x 2310	3140 x 3030		
Die front finishing	P-VAPOX(SiO2) /	P-VAPOX(SiO2) /	P-VAPOX(SiO2) /		
	NITR	NITR	NITR		
Die back finishing	RAW SILICON	RAW SILICON	RAW SILICON		

Construction analysis

See Construction analysis report N° CA MALTA HPC38/06, HPC39/06, HPC40/06 – CTLib numbers 27565, 27566, 27567 - Written by Clifford CALLUS (October 10, 2006).

Lot traceability

A563 lot 521 lot A207 lot

Assy lot number: H6073850=1 Assy lot number: H606318=1 Assy lot number: H547469=1 Wafer lot number: VH607385 Wafer lot number: VH606318 Wafer lot number: VH547469

▲▼ (e3) ABQ TDA7438D TEA6422 TDA7468D 7B222 VH 7B222 VH 7B222 VH PHL 99 614 PHL 99 614

DATE 19-JUL-2007

REVISION A

Line	Final test	Reliability plant	Particular points
A563	MUAR	MUAR	
A521	MUAR	MUAR	
A207	MUAR	MUAR	

		REJECTED PARTS		
TEST	CONDITIONS	A563	A521	A207
JL3	Preconditioning - T-SCAN + C-SAM @ time 0 - 24h bake @ 125°C - 192h @ 30°C / 60% RH - Reflow simulation (3 times) with standard JEDEC profile @ 260°C - T-SAM + C-SAM after reflow	0/150	0/150	0/150
JL3 + HdTS	Humidity storage Ta=85°C/85%Rh Steps: 0, 168, 500, 1000 hours T-SCAN + C-SAM after 1000 hours	0/50	0/50	0/50
JL3 + TCT	Thermal cycling Ta=-40/+150°C Steps: 0, 100, 500, 1000 cycles T-SCAN + C-SAM after 1000 cycles	0/50	0/50	0/50
HTS	High temperature storage Ta=150°C Steps: 0, 168, 500, 1000 hours T-SCAN + C-SAM after 1000 hours	0/50	0/50	0/50
JL3 + PPT	Pressure pot P=2atm, Ta=121°C, 100%RH Steps: 0, 168, 240h T-SCAN + C-SAM after 240h	0/50	0/50	0/50

Delamination issues on A521 lot

Resin-Lead delamination observed on 1/10 samples of A521 lot in construction analysis.

Initial traces of bottom pad delamination were found on parts n°11, 20 & 21 of A521 lot. After the JL3 step, this delamination extends to 100% of the die pad (bottom) for the same 3 parts.

After HdTS, part n°21 presents 100% of the die pad (bottom) delamination.

After TCT, all parts present 50 to 100% of the die pad (bottom) delamination.

After PPT, part n°6 presents 100% of the die pad (bottom) delamination.

A Temporary Instruction (TIHPC06-44-A) was put in place to monitor this issue: on all the production, sample 2 strips per assembly lots and perform SAM (top & bottom) during 3 months. All results of this TI are ok.

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Annex: Reliability tests description

TEST NAME	DESCRIPTION	PURPOSE
JLn:	The device is submitted to a typical	As stand-alone test: to investigate the level of moisture
JEDEC Level n	temperature profile used for surface	sensitivity.
surface	mounting, after controlled moisture	As preconditioning before other reliability tests: to verify
mounting	absorption.	that the surface mounting stress does not impact on the
simulation		subsequent reliability performance.
		The typical failure modes are "pop corn" effect and
		delamination.
TCT:	The device is submitted to cycled	To investigate failure modes related to the thermo-
Temperature	temperature excursions, between a hot and a	mechanical stress induced by the different thermal
Cycles Test	cold chamber in air atmosphere.	expansion of the materials interacting in the die-package
		system. Typical failure modes are linked to metal
		displacement, dielectric cracking, molding compound
		delamination, wire-bonds failure, and die attach layer
		degradation.
PPT:	The device is stored in saturated steam, at	To investigate corrosion phenomena affecting die or
Pressure Pot	fixed and controlled conditions of pressure	package materials, related to chemical contamination and
Test	and temperature.	package hermeticity.
HTS:	The device is stored in unbiased condition	To investigate the failure mechanisms activated by high
High	at the max. Temperature allowed by the	temperature, typically wire-bonds solder joint ageing,
Temperature	package materials, sometimes higher than	data retention faults, metal stress voiding.
Storage	the max. Operative temperature.	
HdST:	The device is stored at controlled conditions	To investigate failure mechanisms activated in the die-
Humid Storage	of temperature and relative humidity.	package environment by wet conditions. Typical failure
Test		mechanisms are corrosion and surface effects related to
		the molding compound.

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